

Role of gallium diffusion in the formation of a magnetically dead layer at the $\text{Y}_3\text{Fe}_5\text{O}_{12}/\text{Gd}_3\text{Ga}_5\text{O}_{12}$ epitaxial interface

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We have clarified the origin of a magnetically dead interface layer formed in yttrium iron garnet (YIG) films grown at above 700 °C onto a gadolinium gallium garnet (GGG) substrate by means of laser molecular beam epitaxy. The diffusion-assisted formation of a Ga-rich region at the YIG/GGG interface is demonstrated by means of composition depth profiling performed by x-ray photoelectron spectroscopy, secondary ion mass spectroscopy, and x-ray and neutron reflectometry. Our finding is in sharp contrast to the earlier expressed assumption that Gd acts as a migrant element in the YIG/GGG system. We further correlate the presence of a Ga-rich transition layer with considerable quenching of ferromagnetic resonance and spin wave propagation in thin YIG films. Finally, we clarify the origin of the enigmatic low-density overlayer that is often observed in neutron and x-ray reflectometry studies of the YIG/GGG epitaxial system.

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I. INTRODUCTION

The intense interest in nanometer-scale epitaxial films of yttrium iron garnet ($\text{Y}_3\text{Fe}_5\text{O}_{12}$, YIG) is supported by potential applications in magnonic devices [1–3], exploiting the idea of data transfer via spin waves (SWs) [4]. Magnonic applications are based on nanostructures, where SW can propagate with reduced loss over distances up to millimeters. The extremely low Gilbert damping parameter $\alpha = 3.0 \times 10^{-5}$ and the narrowest ferromagnetic resonance (FMR) linewidth of $\Delta H = 0.2$ Oe of single-crystalline YIG make it one of the best materials in the field. Due to the absence of three-magnon scattering [5], the spin wave damping is expected to be significantly lower in YIG ultrathin films with thickness ranging from a few nanometers to a few tens of nanometers. For example, it was shown recently in Ref. [6] that SW damping in a 10 nm epitaxial YIG layer can be as low as $\alpha = 3.6 \times 10^{-5}$, approaching the bulk value obtained for YIG single crystals grown by the Czochralski method. Various deposition techniques including laser molecular beam epitaxy (LMBE) have been used [6–14] in recent years to grow high-quality YIG films onto gadolinium gallium garnet ($\text{Gd}_3\text{Ga}_5\text{O}_{12}$, GGG) substrates. Despite the fact that GGG is very well lattice matched to YIG ($\Delta a/a = 6 \times 10^{-4}$), it was claimed in a number of studies that the crystal structure and magnetic properties of YIG nanolayers can be quite different

from the bulk. Particularly, the (111) interlayer spacing in films is often significantly larger (by 1–1.5%) than in bulk YIG due to rhombohedral distortions [13,14]. This can be caused by stoichiometry deviations due to oxygen and iron vacancies, gallium or gadolinium diffusion from the substrate, etc. Magneto-optical studies of YIG/GGG nanoheterostructures reveal a modified magnetic structure of the interface region [15]. X-ray reflectivity measurements [16] confirm the presence of a few-nm interface layer with a reduced density and magnetization. There exists a single polarized neutron reflectometry (PNR) study [16] showing that the interface region is paramagnetic at room temperature but becomes magnetic at 5 K and couples antiparallel to the rest of the YIG film. Although some considerations are given therein that the interface region consists of Gd doped YIG, there is no direct evidence that the migrant element is not Ga. Moreover, scanning electron microscopy (SEM) and electron energy loss spectroscopy (EELS) have shown [16] that the interface is chemically diffused and both Ga and Gd penetrate into the YIG film. Similarly a 5 nm thick interdiffusion region with almost zero magnetic moment was detected by PNR [17]. Energy dispersive x-ray spectroscopy (EDX) studies of YIG/GGG layers grown at 700 °C [18] were interpreted in terms of a symmetrical interpenetration of Ga, Gd, Fe, and Y rather than an interdiffusion of specific elements. No asymmetrical interdiffusion was observed in YIG films grown by liquid phase epitaxy [19,20]. One can expect that this is because the growth rate in LPE is 10–100 times (micron per min) higher than in Laser MBE (10 nm/min) so the atoms

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cannot propagate far by diffusion, at least in the films of comparable thickness. The other reason for the appearance of excess Ga or Gd at the interface in YIG/GGG films grown by Laser MBE could be some resputtering of the substrate by energetic plasma.

In the present work we investigated in detail the YIG/GGG epitaxial layers grown at 700–1000 °C by laser MBE, paying particular attention to the properties of the interface region. We studied the correlations between crystal structure, chemical composition, and magnetic characteristics of thin YIG/GGG layers. We demonstrate drastic quenching of ferromagnetic resonance and spin wave propagation in ultrathin YIG films, correlating it to the structural data obtained by composition depth profiling. Secondary ion mass spectroscopy, x-ray photoelectron spectroscopy, atomic force microscopy, and x-ray and neutron reflectometry are applied to demonstrate that a Ga-rich layer is formed at the bottom of the YIG film during high-temperature epitaxial growth. The direct observation of Ga diffusion into the YIG film is in contrast to the earlier works claiming that the migrant element is Gd. The origin of the thin low-density layer residing on top of the YIG layer is also explained. The presented results are specific for YIG layers grown by laser MBE and do not necessarily apply to the other growth techniques such as liquid phase epitaxy.

II. EXPERIMENT

The epitaxial YIG layers were grown at 700–1000 °C by laser molecular beam epitaxy onto annealed GGG (111) substrates, following the approach addressed in our earlier works [13,14]. As described therein, growth results in high-quality YIG films with sharp x-ray diffraction Bragg peaks, high-contrast Laue oscillations, smooth atomically flat surface, ultranarrow magnetization loops, and a low spin-wave damping coefficient [6]. The surface morphology characterization by atomic force microscopy (Fig. 1) showed that YIG layers are atomically flat, exhibiting the step-and-terrace surface morphology that is typical of layer-by-layer growth. The well-pronounced high-energy electron diffraction (RHEED) intensity oscillations [Fig. 1(b)] were observed during film deposition, confirming the layer-by-layer growth and allowing precise calibration of the growth rate and film thickness.

X-ray photoelectron spectroscopy (XPS) measurements were carried out to study chemical composition and oxidation state in the near-surface region. A Physical Electronics 15-255G AR double-pass cylindrical-mirror electron energy analyzer and a double anode XR3 x-ray source (VG Microtech) operated at 15 kV, 18 mA for Mg $K\alpha$ photons were used. No surface sputtering was performed prior to XPS studies, as it is known to change the oxidation state of Fe. Secondary ion mass spectroscopy (SIMS) was applied for chemical composition depth profiling. The mass spectra of positive secondary ions were collected from a 150 μm area using 25 kV Bi ions. Sputtering was performed applying 1 kV Ar ions in a 200 μm crater.

PNR was applied to probe depthdependent nuclear and magnetic scattering length densities. The measurements were performed at the Super ADAM setup [21] (Institut Laue-Langevin, Grenoble, France) with a monochromatic beam (wavelength $\lambda = 5.18 \text{ \AA}$) and polarization $P = 99.8\%$. The

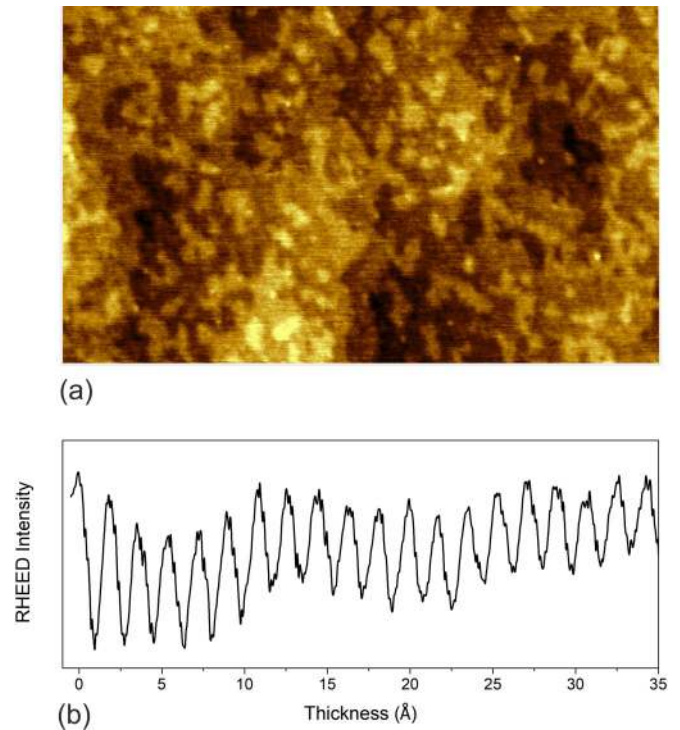


FIG. 1. The AFM image of the step-and-terrace surface morphology observed in a 20 nm thick YIG layer grown at 850 °C (a). The AFM image size is 600 nm \times 1000 nm \times 1 nm. The RHEED intensity oscillations are observed during the layer-by-layer YIG growth (b).

neutron reflectivity for polarizations parallel (R^+) and antiparallel (R^-) to the in-plane magnetic field of 500 Oe was measured as a function of temperature. X-ray reflectivity (XRR) was used complementary to PNR to get information on the electronic density depth profiles. The reflectivity curves were measured at a wavelength of $\lambda = 1.04 \text{ \AA}$ at the BL3A beamline of the Photon Factory synchrotron (Tsukuba, Japan). The fitting of PNR and XRR was performed using the GENX package [22].

The high-frequency magnetic response of the YIG films was measured by ferromagnetic resonance (FMR) and spin wave propagation spectroscopies to get complementary information on the standing and traveling spin waves. FMR spectra were measured with a conventional electronic paramagnetic resonance (EPR) spectrometer at a fixed microwave frequency of 9.4 GHz. The spin wave propagation was studied in a Damon-Eshbach setup [23]. The YIG/GGG samples were placed on the microstripe antennas with 30 μm thickness, 2 mm length, and 1.2 mm separation. The transmission coefficient S_{21} was measured with a Rohde-Schwarz ZVA-40 vector network analyzer in a fixed magnetic field of 550–650 Oe applied in-plane.

The choice of YIG film thickness was guided by the need to distinguish the modified interface from the main YIG layer. For the depth resolving methods such as SIMS, PNR, and XRR, the total film thickness (16–20 nm) was chosen to significantly exceed the dead layer thickness (few nm). With those techniques for which depth sensitivity was not available, we studied thickness series of 4–6–15–25 nm by FMR and

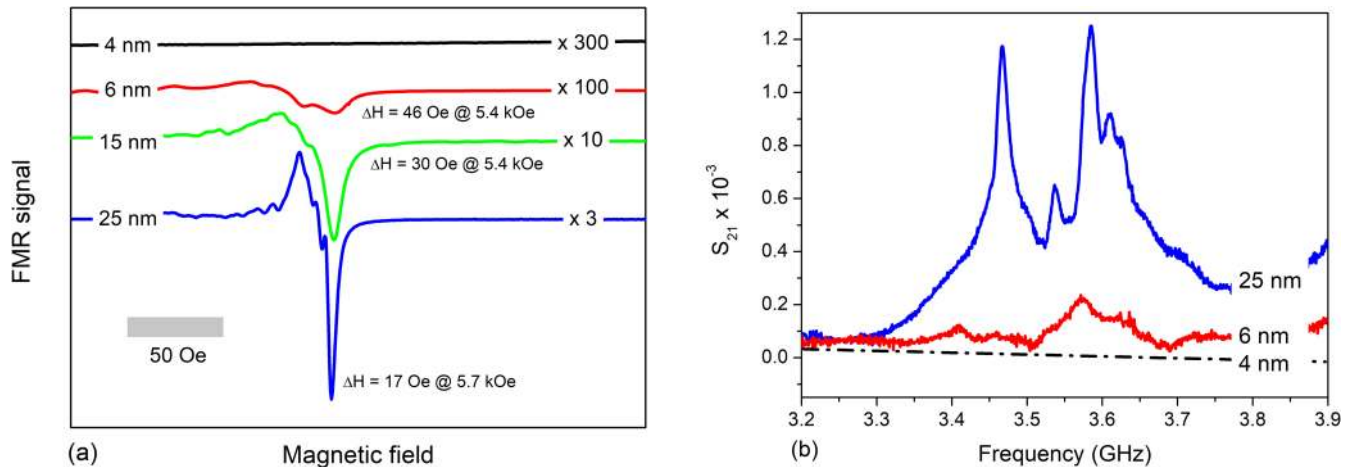


FIG. 2. The weakening of the high-frequency magnetic response in ultrathin YIG films as demonstrated by FMR (a) and spin wave transmission (b) spectra in a series of YIG layers with different thickness. The FMR spectra are measured in the magnetic field perpendicular to the film plane. The spectra are scaled, shifted vertically, and aligned horizontally for ease of comparison.

SW spectroscopies and 4–13 nm by XPS. The main results in this paper were obtained for the films grown at 700–850 °C. At a higher growth temperature of 1000 °C it was difficult to keep stoichiometry (as shown in the XPS section below). We did not go lower than 700 °C, as in this case the crystalline quality deterioration needs compensation by post-growth annealing.

III. QUENCHING OF HIGH-FREQUENCY DYNAMIC MAGNETIC PROPERTIES IN ULTRATHIN YIG FILMS

As demonstrated in Ref. [16] by measuring $M(H)$ loops of YIG films with different thicknesses, the saturation magnetization decreases linearly with the decrease of the film thickness and approaches zero at a film thickness of 6–7 nm. This indicates that a magnetically dead layer is present at the YIG/GGG interface from the point of view of static magnetometry. Taking into account that the high-frequency magnetic response of YIG layers is very important in spintronic applications, we have performed a similar study with respect to the dynamic magnetic properties. We have investigated the thickness dependence of the ferromagnetic resonance and spin wave propagation.

Figure 2(a) shows the FMR spectra measured in a series of YIG layers of different thicknesses. One can clearly observe that while the film thickness is decreasing from 25 nm to 6 nm, the FMR line is getting wider and lower in intensity. The resonance is still detectable but extremely weak in the 6 nm YIG film, and no FMR signal can be found in the 4 nm film. A similar behavior of the FMR linewidth as a function of film thickness was reported earlier by Sun *et al.* [7]. Spin wave propagation shows the same trends: as shown in Fig. 2(b) for the same thickness series of YIG samples, the spin wave transmission coefficient S_{21} drastically decreases with the decrease of the film thickness from 25 nm to 6 nm. The response of the 4 nm film is only traced schematically as a flat line in Fig. 2(b); the signal measured did not emerge above the noise level for this film. The shape of the spin wave transmission spectrum with additional peaks at lower values of effective magnetization $4\pi M - H_a$ (where $4\pi M$ is the magnetization and H_a is the uniaxial anisotropy field) can be

a result of depth inhomogeneity, indicating the presence of a transition layer between the GGG substrate and the YIG film. The highest transmission coefficient of -29 dB was observed in the 25 nm YIG film.

IV. DEPTH-RESOLVED CHEMICAL COMPOSITION OF YIG/GGG FILMS BY SIMS AND XPS

The quenching of static and dynamic magnetic properties in ultrathin YIG layers suggests that a magnetically dead layer exists at the YIG/GGG interface. In order to shed light on the origin of this layer, two complementary methods, SIMS and XPS, were applied in the present work to study the depth-dependent chemical compositions of the YIG/GGG layers. SIMS was used to obtain element-selective depth profiles, without quantitative evaluation of the element concentrations. XPS was used to nondestructively obtain the chemical composition of the YIG film near-surface region and to monitor the iron oxidation states. The SIMS profiles of Fe, Y, Ga, and Gd measured in YIG layers grown at 700 °C and 850 °C are shown in Fig. 3. The profiles are corrected to give flat 100% concentration of Ga and Gd deep inside the GGG substrate. The gray rectangle marks an approximately 7 nm thick region, where the profiles show similar broadening, due to film inhomogeneity. The features present in this region cannot be easily interpreted as they correspond to a convolution of concentration, substrate roughness, film inhomogeneity, and change of the ionization efficiency at the interface.

Interestingly, in all the studied samples the Ga concentration profiles extend up to 5–7 nm deep into the YIG film, while the Gd profile sharply drops to zero beyond the gray-labeled broadening region. This observation suggests that diffusion of Ga atoms into the film occurs during the growth. The Fe:Y ratio noticeably decreases towards the interface in the samples grown at 850 °C and stays almost constant in the YIG film grown at 700 °C. Thus, we believe that during the high-temperature growth stage the iron atoms in YIG are partially substituted with gallium atoms that penetrate into the YIG film from the GGG substrate to a depth of several nanometers. The back diffusion of Fe and Y into the substrate, if any, is difficult

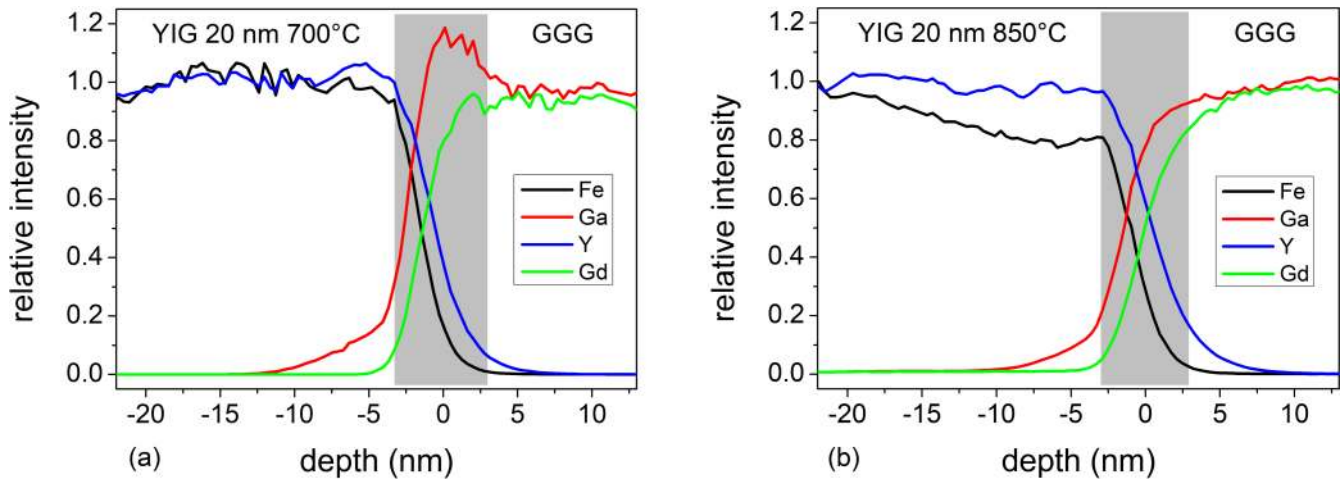


FIG. 3. SIMS profiles of Fe, Y, Ga, and Gd positive ions measured in YIG layers grown at 700 °C (a) and 850 °C (b). The profiles illustrate noticeable Ga diffusion into the YIG film interfacial region and variation of Fe:Y ratio in the 850 °C film.

to estimate accurately, as the border between the “gray” transition layer and the substrate is not well defined. While Y tends to extend farther into GGG than Fe, it can be also due to an instrumental effect. The observed Ga/Fe concentration profile behavior resembles that reported by Ukleev *et al.* [24] for the $\epsilon\text{Fe}_2\text{O}_3/\text{GaN}$ system, where the partial substitution of iron by gallium in the interface region was demonstrated by SIMS.

The wide range x-ray photoemission spectra measured in 13 nm films grown at 850 °C and 1000 °C, 4 nm film grown at 850 °C, and clean GGG(111) substrate are shown in Fig. 4. Characteristic photoemission and Auger peaks of Fe, Y, O (YIG film), Ga, Gd (GGG substrate), and C, N (post growth contaminants) show up, confirming the chemical purity of the YIG films. The Fe $2p$, Y $3p$, Y $3d$, and O $1s$ photoemission spectra are shown in higher resolution in Fig. 5. The levels of yttrium and oxygen are not much varied in the studied samples. The amount of Fe on the surface is the lowest in the 4 nm sample grown at 850 °C, is slightly higher in the 13 nm sample grown at 850 °C, and is the highest in the 13 nm sample grown at 1000 °C. In a similar study of PLD grown YIG/GGG films [7], the Y:O ratio was claimed to be constant (3:12), while the Y:Fe ratio was shown to vary from 3:2.1 to 3:2.6 corresponding to iron deficiency (it should be 3:5 in stoichiometric $\text{Y}_3\text{Fe}_5\text{O}_{12}$). The Fe content was stated to increase with the growth of the temperature. Our finding is consistent with this observation.

As shown in Fig. 5, the Fe $2p_{3/2}$ and $2p_{1/2}$ peaks are positioned at 710.9 and 724.5 eV, respectively, independent of the growth conditions. No indication of metallic Fe at 707 eV [26] is present. The positions of Fe $2p$ peaks are often used to estimate the presence of Fe $2+$ / $3+$ valence mixing. For example, in Ref. [27] such mixing was claimed to exist in Bi substituted YIG films grown by PLD. Similar considerations were given in Ref. [28] for Zr doped YIG, in Ref. [29] for Ce doped YIG, and in Ref. [30] for Bi doped YIG films obtained by magnetron sputtering. Due to the existing ambiguities regarding the absolute positions of Fe $^{2+}$ and Fe $^{3+}$ peak maxima, it is more appropriate to distinguish

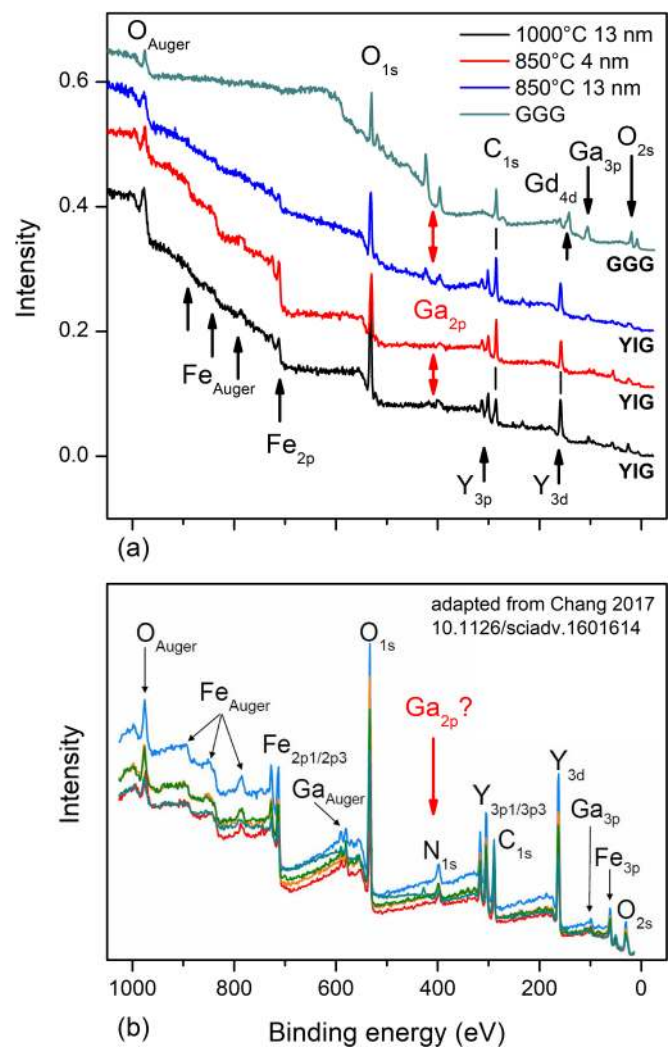


FIG. 4. Wide energy range XPS spectra measured for GGG substrate and a series of YIG/GGG layers grown at 850–1000 °C (a). Shown for comparison are the XPS spectra measured for sputter annealed 20 nm YIG/GGG layers adapted from Ref. [25] (b).

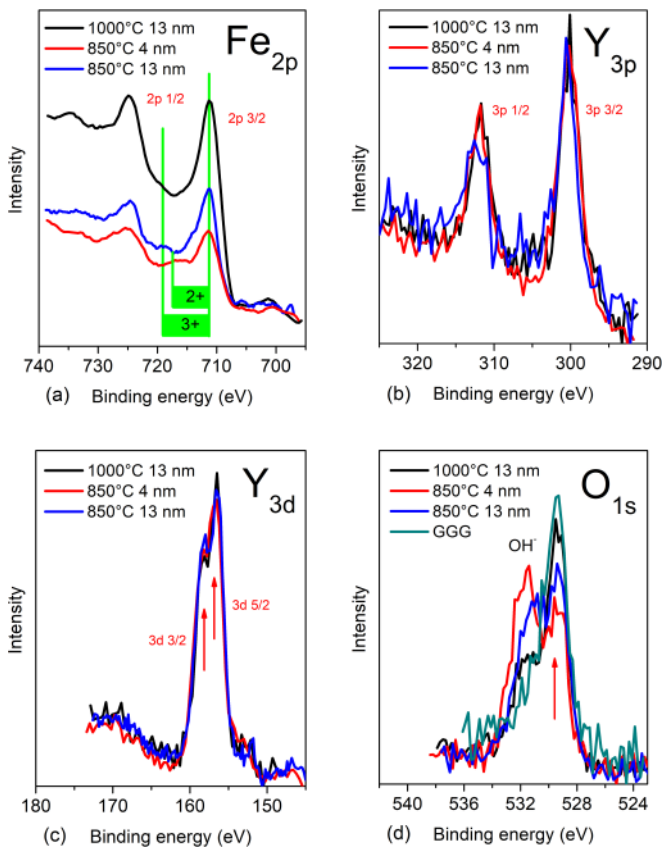


FIG. 5. XPS spectra of Fe $2p$, Y $3p$, Y $3d$, and O $1s$ measured in a series of YIG films grown on GGG at 850–1000 °C. To facilitate the comparison of the spectral shapes and intensities, the background is subtracted, and the normalization to yttrium is performed for every spectrum.

Fe $^{3+}$ from mixed Fe $^{3+}$ /Fe $^{2+}$ by the satellite shoulder that appears at the high binding energy side of the $2p_{3/2}$ peak at a distance of ~ 8 eV for pure 3+ and ~ 6 eV for pure 2+. In mixed valence compounds such as Fe $_3$ O $_4$, the satellite is usually not prominent due to the superposition of Fe $^{2+}$ and Fe $^{3+}$ associated satellites. In XPS studies related to thick YIG films, the 3+ satellite is usually observed [7,25,29,31], indicating the domination of Fe $^{3+}$. In the Fe $2p$ spectra shown in Fig. 5(a), the 4 nm film grown at 850 °C exhibits a trace of 2+ satellite, while 13 nm films grown at 850 °C and 1000 °C films show a signature of 3+ satellite. Thus, it is likely that the Fe $^{3+}$ state characteristic for bulk YIG is mostly obtained in thick YIG films, while in the thin YIG film there is a trace of 2+ iron. As shown in [32], the presence of Fe 2+ ions in thin YIG film can lead to significant increase of the FMR linewidth at low temperature.

The O $1s$ spectra in Fig. 5(d) show two peaks at binding energies of 529.5 and 531.6 eV. Of these two, the peak at lower binding energy (which is the only one observed in the GGG substrate) corresponds well to the position reported for Fe $_2$ O $_3$, Y $_2$ O $_3$, and Y $_3$ Fe $_5$ O $_{12}$ [31,33,34]. The second peak on the high binding energy side is supposed to be related to the hydroxide group due to surface contamination [31,35].

Interestingly, the XPS spectrum of the 4 nm YIG film grown at 850°C shows a noticeable Ga $2p$ peak [Fig. 6(a)].

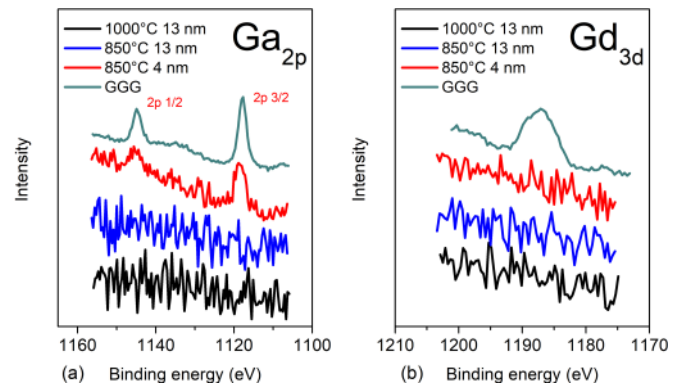


FIG. 6. XPS spectra of Ga $2p$ (a) and Gd $3d$ (b) measured in the GGG substrate and in YIG/GGG films grown at 850–1000 °C.

At the excitation energy of the used photon (1253.6 eV), the kinetic energy of the photoelectrons is low, corresponding to the minimum of the mean free path for electrons in solids. Even forcing the assumption that these photoelectrons are excited in the substrate and they are only slightly attenuated by the 4 nm YIG layer, one would expect to observe also the Gd $3d$ peak (of comparable kinetic energy), along with the Ga $2p$ peak. In GGG, these two peaks have comparable intensities [see the XPS spectrum of GGG in Fig. 4(a)] and similar attenuation depths. The fact that the Gd $3d$ peak is not observed in the 4 nm film [Fig. 6(b)] is strong evidence that Ga is present in the thin YIG layer. From the absence of the Ga $2p$ peak in the 13 nm films, we conclude that Ga is only present in the few-nanometer thick interface region of the YIG film. The slight gallium concentration increase in the vicinity of the YIG/GGG interface was previously reported by XPS [19]. A gallium signature was also reported in Ref. [25], where YIG layers of 20 nm thickness were grown on GGG (111) by magnetron sputtering at room temperature followed by a few hours of annealing in oxygen at 800 °C. The XPS spectra presented in Ref. [25] show noticeable traces of Ga (both Auger and PE peaks) that are, however, claimed by the authors to come from the GGG substrate. This is arguable as the photoelectrons excited in the GGG substrate are not supposed to be able to escape through a 20 nm thick YIG film. Moreover, if Ga photoemission from the substrate is visible, so would be the Gd photoemission, especially at low binding energies for which electron kinetic energies are high. However, the Gd $4d$ peak at 142 eV is not present in these spectra (see Fig. 4). This leads to a conclusion that in the YIG films discussed in [25] Ga diffusion from the substrate might be also present.

V. COMPOSITION AND MAGNETIZATION IN-DEPTH PROFILING BY PNR AND XRR

To further analyze the composition and magnetization depth profiles in the YIG/GGG system, we have applied polarized neutron and x-ray reflectometry techniques. The joint use of both methods gives the advantage of complementary information: nuclear ρ_n and magnetic ρ_m scattering length densities (SLD) by PNR and electron ρ_e density by XRR. Despite the rather moderate contrast of the real parts of ρ_n

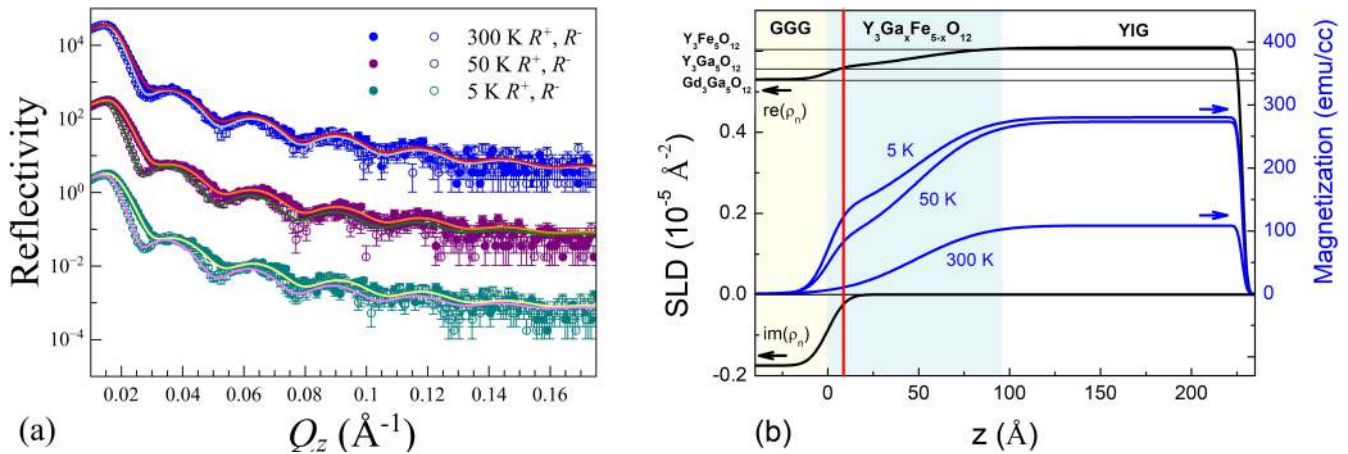


FIG. 7. (a) PNR curves of 23 nm $\text{Y}_3\text{Fe}_5\text{O}_{12}$ film grown at 700°C measured at the applied magnetic field $H = 500$ Oe at $T = 300, 50,$ and 5 K. Symbols correspond to the experimental data points, while the solid lines show the fitted curves. (b) Nuclear and magnetic SLD profiles of the YIG/GGG heterostructure are obtained from the fitting routine. The bulk SLD values of the compounds are shown with the horizontal lines.

and ρ_e in YIG/GGG, gadolinium can be reliably distinguished from the other elements by the noticeable contribution to the imaginary part of the nuclear SLD. In our study, the reflectivity measurements were carried out for two samples: 23 nm YIG film grown at 700°C was studied by PNR and 16 nm film grown at 850°C was studied by XRR.

For quantitative discussions of nuclear, magnetic, and electronic density distributions across the heterostructure we performed fitting using the Parratt algorithm [36] in the GENX software package [22]. The fitting was performed using the simplest possible model. To avoid stagnation of the algorithm to a local minimum, the PNR fit was performed simultaneously for all the experimental data; all the structural parameters were kept constant between the PNR curves measured at different temperatures and magnetic fields, while the magnetizations of layers were varied. In what follows we plot the output of the fitting algorithm as the depth profiles of the complex density: nuclear and magnetic for PNR or electronic for XRR.

The experimental and fitted PNR curves measured at $T = 300, 50,$ and 5 K for 23 nm YIG sample are shown in Fig. 7(a). A reasonable fitting was obtained with a three-layer model containing the substrate, transition layer, and main YIG layer. The nuclear SLDs of the GGG substrate and main YIG layer were fixed to the bulk densities. The transition layer was modeled by $\text{Gd}_x\text{Y}_{3-x}\text{Ga}_y\text{Fe}_{5-y}\text{O}_{12}$ chemical composition assuming the gradual substitution of Gd atoms by Y atoms and Ga atoms by Fe atoms. The depth-resolved structural and magnetic SLD profiles delivered by fitting are shown in Fig. 7(b). Interestingly, the resultant profiles of the real and imaginary parts of ρ_n show drastically different behaviors. Due to the noticeable neutron absorption of Gd nuclei, the imaginary part of ρ_n is proportional to Gd concentration. According to our fitted model $\text{Im}(\rho_n)$ drops sharply at $z = 0$, indicating sharpness of the Gd profile. The observed Gd gradient is in agreement with the typical values of the GGG substrate surface roughness [13]. No noticeable diffusion of Gd atoms into the YIG film is observed. At the same time, the real part of SLD exhibits a smooth gradient extended

by approximately 70 \AA into the YIG film. The SLD value just above the interface [marked with a red line in Fig. 7(b)] fits well to the SLD of $\text{Y}_3\text{Ga}_5\text{O}_{12}$ compound produced by the substitution of Fe atoms in YIG on Ga, which is in agreement with the SIMS and XPS data described above. The composition of the transition layer can be reasonably modeled by the $\text{Y}_3\text{Ga}_y\text{Fe}_{5-y}\text{O}_{12}$ formula that corresponds to the gradual transition from $\text{Y}_3\text{Ga}_5\text{O}_{12}$ to $\text{Y}_3\text{Fe}_5\text{O}_{12}$.

Figure 7(b) shows the temperature-dependent magnetization depth profiles derived from the magnetic SLD ρ_m . The magnetic SLD ρ_m is directly proportional to the magnetization component M parallel to the in-plane magnetic field: $\rho_m = 2.853 \times 10^{-9} \times M \text{ \AA}^{-2}$, where M is given in emu/cm^3 units. The magnetization changes almost synchronously with the real part of the nuclear SLD ρ_n . At room temperature the magnetization of the main YIG layer equals 105 emu/cm^3 , which is slightly lower than the saturation magnetization $M_s = 140 \text{ emu/cm}^3$ of the bulk YIG [37] but comparable to room temperature M_s values discussed in Ref. [16]. The magnetization of the transition layer drops gradually towards the YIG/GGG interface synchronously with the Ga-Fe substitution. In contrast to the recent works [16,38], we have not observed any antiparallel magnetic moment at the interfacial region at low temperatures. The different magnetic properties of the interface region could be the result of a different way of YIG film preparation: while we grow the film in one stage, the authors of Refs. [16,38] use a 2 h post-growth annealing. According to our experiment, the small parallel magnetic moment is observed in the interface layer at 5–50 K. The magnetization of the main YIG layer increases drastically as the temperature decreases to 5 K, in agreement with Refs. [37] and [16].

The fitted x-ray reflectivity curve measured in 16 nm $\text{Y}_3\text{Fe}_5\text{O}_{12}$ is shown in Fig. 8(a). A reasonable fit was achieved for a four-layered model containing the GGG substrate, a transition $\text{Y}_3\text{Ga}_x\text{Fe}_{5-x}\text{O}_{12}$ layer, a main $\text{Y}_3\text{Fe}_5\text{O}_{12}$ layer, and a peculiar low-density top layer. The electron densities of the GGG substrate and main YIG layer were fixed to the

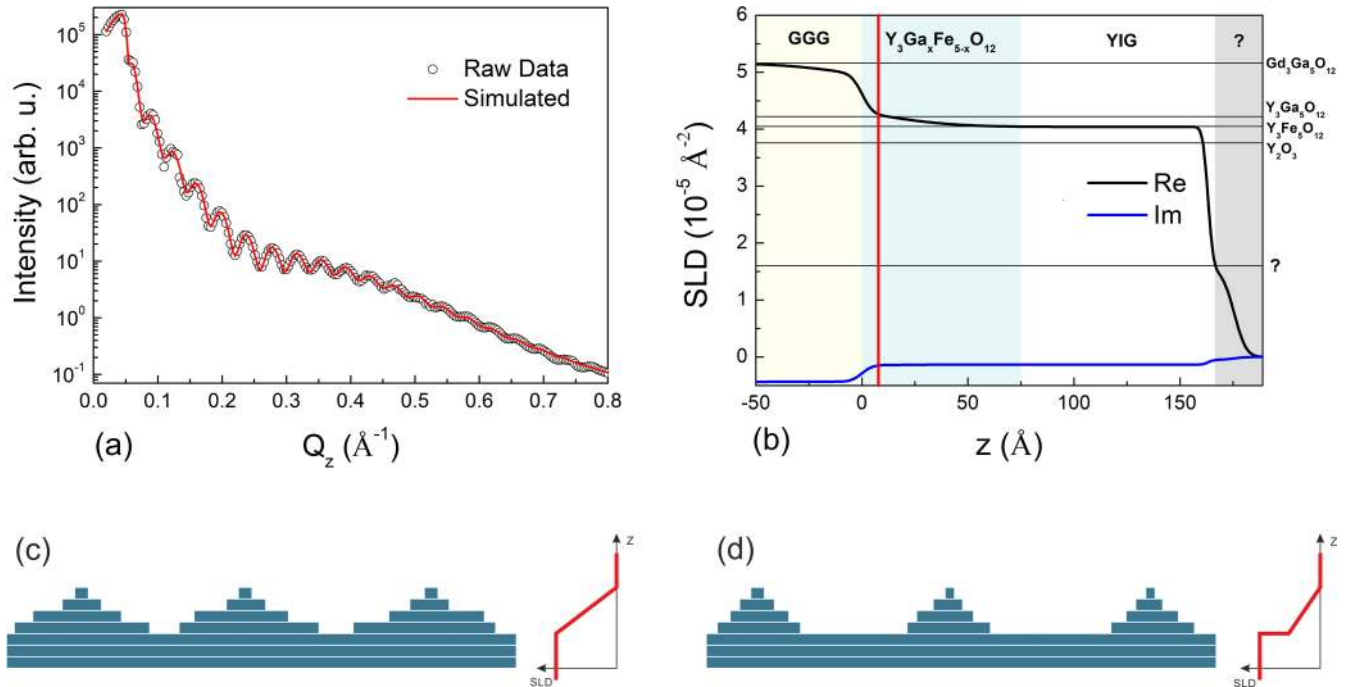


FIG. 8. X-ray reflectivity of 16 nm $\text{Y}_3\text{Fe}_5\text{O}_{12}$ film grown at 850°C (a). Circles represent raw data, and the solid curve is the GENX fitting. Real and imaginary parts of SLD profile for YIG film corresponding to the best fit (b). The bulk SLD values of the involved compounds are shown with the horizontal lines. The low-density top layer is shown in gray and its SLD value is labeled with a question mark symbol. The sketch of the step-and-terrace surface morphologies gives uniformly sloped (c) and stepped (d) density profiles.

corresponding bulk values. The resultant SLD profile in Fig. 8(b) exhibits a sharp drop at $z = 0 \text{ \AA}$, followed by a slow density decrease towards $z = 70 \text{ \AA}$. At this point the density becomes equal to the SLD value of YIG bulk. Following the same strategy as in the PNR section above, we assume that the double slope observed is the superposition of the sharp depth profile of Gd and the sloping profile of the Ga distribution, expanding by diffusion into the YIG layer. This assumption is in quantitative agreement with the density profile, as the SLD value just above the interface [marked with the red line in Fig. 8(b)] fits well to the electron density of the $\text{Y}_3\text{Ga}_5\text{O}_{12}$ compound produced by substituting all Fe atoms in YIG by Ga. The rest of the slope can be modeled by assuming the gradual transition from the compound of $\text{Y}_3\text{Ga}_5\text{O}_{12}$ to the compound of $\text{Y}_3\text{Fe}_5\text{O}_{12}$. The $\text{Y}_3\text{Ga}_x\text{Fe}_{5-x}\text{O}_{12}$ composition of the transition layer with x changing from 5 down to 0 on the length scale $50\text{--}70 \text{ \AA}$ correlates well with the Ga diffusion discussed above.

Interestingly, the obtained SLD profile suggests that a 15 \AA top layer with reduced density exists on the top of the YIG surface. Without this layer it is impossible to model the low-frequency oscillations in the reflectivity curve having maximum at $Q_z = 0.4 \text{ \AA}^{-1}$ in Fig. 8(a). A similar feature attributed to oxidation or contamination was also present in the XRR data in Ref. [39]. The low-density layer residing at the YIG surface is considered to be Y_2O_3 in the PNR study of Cooper *et al.* [17]. However, we believe that this is not the case, as the SLD of Y_2O_3 ($3.75 \times 10^{-5} \text{ \AA}^{-2}$) is significantly larger than the density value observed in our work and in [17]. We think that the low-density layer is instead related to the particularly organized step-and-terrace structure of the YIG

surface. As evidenced by AFM studies [6,13,14], the YIG surface is terminated by a multistoried structure consisting of (111) monolayers. When the level occupancy is uniformly decreasing towards vacuum, XRR can be modeled by the Gaussian surface roughness [Fig. 8(c)]. If the level occupancy distribution function shows a jump, the density profile will show a jump as well [Fig. 8(d)].

The uneven level occupancy might be caused by the adatom migration that occurs when deposition has stopped but the substrate temperature is still high. The low-frequency modulations often observed around the 444 and 888 Bragg reflections provide important evidence that the low-density layer has the layered crystal structure of YIG. Notably, the presented XRR and PNR data are in general agreement with each other. As the spanned Q_z range accessed by PNR (0.18 \AA^{-1}) is significantly narrow in comparison with XRR (0.8 \AA^{-1}), the neutron reflectivity curve does not show the characteristic low-frequency modulation and, therefore, provides no evidence of a 15 \AA thin low-density layer residing on top of the YIG surface. We expect that such evidence would become available if the PNR was measured to a higher value of Q_z . Taking into account the data of the other groups [39] as well as our own preliminary XRD studies (to be presented elsewhere), we believe that the low-density layer exists as well in the 700°C layer.

VI. CONCLUSION

In our paper, we shed light on the origin of the few-nanometer-thick magnetically dead layer present at the interface of the epitaxial YIG/GGG layers grown above 700°C by

means of laser MBE. Previously, the existence of such a layer was mainly suggested based on results of indirect methods, such as static magnetometry measurements. In the present work, we directly show this effect in thin YIG films by means of the ferromagnetic resonance, spin wave propagation, and polarized neutron reflectometry. We have demonstrated that the resonance magnetic properties are noticeably quenched as the YIG film thickness decreases to a value of few nanometers. As opposed to the previous works [16] and [17], where the magnetically dead layer was claimed to be due to Gd diffusion, our SIMS, XPS, XRR, and PNR measurements have shown no trace of Gd migration into the YIG layer. We have revealed a 5–7 nm interface region in the YIG layer that is Ga rich and deficient of Fe. The Ga diffusion was further confirmed by the reflectivity measurements performed by polarized neutrons and x rays. The PNR study showed that the magnetization within the dead layer gradually decreases from the quasibulk value in the main YIG layer to zero at the interface. The magnetization was shown to increase by a factor of 2.5 at low temperature. The small nonproportional increase of magnetization within the interface layer was observed upon the sample cooling below 50 K, possibly due to the magnetic phase transition. To our knowledge, this is the first time that Ga diffusion during YIG/GGG growth has been directly confirmed by a combination of direct space and reciprocal space methods. Interestingly, a peculiar 15 Å low-density layer residing on top of the YIG layer was observed by x-ray reflectivity. In our opinion, this layer cannot be explained by a uniform film of a crystalline phase, as was claimed

in [17] regarding Y_2O_3 . We suggest instead that the peculiar low-frequency oscillations in the XRR reflectivity curve are caused by a nonuniform height distribution within the step-and-terrace multilevel structure at the YIG surface. The presented SIMS, XPS, PNR, and XRR data provide strong evidence that the YIG/GGG interface region is magnetically different from the YIG bulk due to the intermixing caused by Ga diffusion from the GGG substrate. It must be noted that the presented results are specific for the YIG layers grown in the 700–850 °C temperature range in which the YIG/GGG interface peculiarities do not show drastic temperature dependence (with somewhat flatter concentration profiles for 700 °C films). The results are obtained for films grown by laser MBE and do not necessarily apply to the other YIG growth techniques such as liquid phase epitaxy or magnetron sputtering.

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